

O I P E Docket No. NEC00P267-hk

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent application of

Ken Inoue et al.

Serial No.: 09/667,706

Group Art Unit: 2811

Filing Date: September 22, 2000

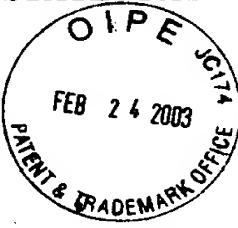
Examiner: Douglas W. Owens

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner of Patents
Washington, D.C. 20231

TC 2800 MAIL ROOM
FEB 25 2003

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INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following document listed on the attached form PTO-1449 and cited in the counterpart Taiwanese Application, to the attention of the Examiner in charge of the above-identified application. A copy of the listed document is provided herewith for the convenience of the Examiner.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which the applicant is aware.

I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

Phillip E. Miller
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Date:

2/24/03

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